

Day : Friday
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PALM INTRANET**Inventor Name Search Result**

Your Search was:

Last Name = SATONAGA

First Name = TOMOHIKO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10467697	7033563	150	08/08/2003	METHOD FOR REDUCING OXYGEN COMPONENT AND CARBON COMPONENT IN FLUORIDE	SATONAGA, TOMOHIKO
10551113	Not Issued	30	06/28/2006	Method for analyzing impurities (color centers) of fluoride and process for producing material for growing single crystal	SATONAGA, TOMOHIKO
*10554424	Not Issued	25	10/26/2006	Apparatus for producing fluoride crystal	SATONAGA, TOMOHIKO
*10564283	Not Issued	30	05/25/2006	Method for producing crystal of fluoride	SATONAGA, TOMOHIKO
10569488	Not Issued	30	06/23/2006	Scintillator and radiation detector, and radiation inspecting device	SATONAGA, TOMOHIKO
11578248	Not Issued	17	03/06/2007	Solid Solution Material Of Rare Earth Element Fluoride (Polycrystal And Single Crystal), And Method For Preparation Thereof, And Radiation Detector And Test Device	SATONAGA, TOMOHIKO

Inventor Search Completed: No Records to Display.

Search Another: Inventor

Last Name

Satonaga

First Name

Tomohiko

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Day : Friday
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PALM INTRANET**Inventor Name Search Result**

Your Search was:

Last Name = KIKUYAMA

First Name = HIROHISA

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>07099463</u>	<u>4795582</u>	150	09/21/1987	SURFACE TREATING COMPOSITION FOR MICRO PROCESSING	KIKUYAMA, HIROHISA
<u>07381914</u>	<u>5009963</u>	150	07/19/1989	METAL MATERIAL WITH FILM PASSIVATED BY FLUORINATION AND APPARATUS COMPOSED OF THE METAL MATERIAL	KIKUYAMA, HIROHISA
<u>07454575</u>	<u>5073232</u>	150	12/21/1989	METHOD OF ANHYDROUS HYDROGEN FLUORIDE ETCHING	KIKUYAMA, HIROHISA
<u>07541871</u>	Not Issued	166	06/21/1990	SURFACE TREATMENT AGENT FOR FINE SURFACE TREATMENT	KIKUYAMA, HIROHISA
<u>07613730</u>	<u>5149378</u>	150	11/21/1990	TUNGSTEN FILM FORMING APPARATUS	KIKUYAMA, HIROHISA
<u>07665767</u>	Not Issued	166	03/07/1991	INDUSTRIAL MATERIAL WITH FLUORINE PASSIVATED FILM AND PROCESS OF MANUFACTURING THE SAME	KIKUYAMA, HIROHISA
<u>07682412</u>	<u>5100495</u>	150	04/08/1991	DRY ETCHING APPARATUS, WITH DILUTED ANHYDROUS HYDROGEN FLUORIDE GAS GENERATOR	KIKUYAMA, HIROHISA
<u>07924574</u>	Not Issued	166	08/05/1992	SURFACE TREATMENT AGENT FOR FINE SURFACE TREATMENT	KIKUYAMA, HIROHISA
<u>08050737</u>	<u>5277835</u>	250	04/21/1993	SURFACE TREATMENT AGENT FOR FINE SURFACE TREATMENT	KIKUYAMA, HIROHISA
<u>08051001</u>	Not Issued	163	04/21/1993	INDUSTRIAL MATERIAL WITH FLUORINE PASSIVATED FILM AND PROCESS OF	KIKUYAMA, HIROHISA

				MANUFACTURING THE SAME	
<u>08281659</u>	Not Issued	161	07/28/1994	SURFACE TREATING COMPOSITION FOR MICRO PROCESSING	KIKUYAMA, HIROHISA
<u>08414973</u>	5714407	150	03/31/1995	ETCHING AGENT, ELECTRONIC DEVICE AND METHOD OF MANUFACTURING THE DEVICE	KIKUYAMA, HIROHISA
<u>08938469</u>	5803956	150	01/11/1996	SURFACE TREATING COMPOSITION FOR MICRO PROCESSING	KIKUYAMA, HIROHISA
<u>09066354</u>	6027571	150	06/29/1998	SURFACE TREATMENT FOR MICROMACHINING	KIKUYAMA, HIROHISA
<u>09125440</u>	6585910	150	03/26/1999	ETCHANT	KIKUYAMA, HIROHISA
<u>09600231</u>	6514474	250	09/05/2000	METHOD OF PURIFYING LITHIUM HEXAFLUOROSPHATE	KIKUYAMA, HIROHISA
<u>09622397</u>	6797194	150	12/01/2000	SURFACE TREATING FOR MICROMACHINING AND METHOD FOR SURFACE TREATMENT	KIKUYAMA, HIROHISA
<u>09699423</u>	6632293	150	10/31/2000	HIGHLY ACTIVATED HYDROGEN CONTAINING MATERIAL AND METHOD FOR PRODUCING THE MATERIAL	KIKUYAMA, HIROHISA
<u>09857117</u>	6699603	150	12/26/2001	STAINLESS STEEL HAVING PASSIVE FLUORIDE FILM FORMED THEREON AND EQUIPMENT MANUFACTURED THEREFROM	KIKUYAMA, HIROHISA
<u>09890470</u>	6905606	150	02/12/2002	METHOD OF REMOVING CALCIUM FROM WATER CONTAINING CALCIUM HYDROGEN CARBONATE IN HIGH CONCENTRATION	KIKUYAMA, HIROHISA
<u>09890754</u>	6666973	150	02/12/2002	METHOD FOR FIXING FLUORINE AND PHOSPHORUS IN WASTE WATER CONTAINING FLUOROPHOSPHORIC ACID-DERIVED COMPOUND TO REMOVE THEM	KIKUYAMA, HIROHISA
<u>10149266</u>	6955795	150	09/25/2002	METHOD FOR PRODUCING LITHIUM	KIKUYAMA, HIROHISA

HEXAFLUOROPHOSPHATE					
10149881	6896866	150	09/25/2002	METHOD FOR PURIFICATION OF TUNGSTEN HEXAFLUORIDE	KIKUYAMA, HIROHISA
10336982	6884403	150	01/06/2003	Method of purifying lithium hexafluorophosphate	KIKUYAMA, HIROHISA
10455628	Not Issued	80	06/06/2003	Highly activated hydrogen containing material and method for producing the material	KIKUYAMA, HIROHISA
10467697	7033563	150	08/08/2003	METHOD FOR REDUCING OXYGEN COMPONENT AND CARBON COMPONENT IN FLUORIDE	KIKUYAMA, HIROHISA
10487770	Not Issued	25	09/08/2006	Surface treating solution for fine processing of glass base plate having a plurality of components	KIKUYAMA, HIROHISA
10488036	Not Issued	25	08/14/2006	SURFACE TREATING FLUID FOR FINE PROCESSING OF MULTI-COMPONENT GLASS SUBSTRATE	KIKUYAMA, HIROHISA
10505802	7175823	150	10/07/2004	PURIFICATION METHOD FOR PRODUCING HIGH PURITY NIOBIUM COMPOUND AND/OR TANTALUM COMPOUND	KIKUYAMA, HIROHISA
10505803	7214362	150	10/07/2004	PURIFICATION METHOD FOR PRODUCING HIGH PURITY NIOBIUM COMPOUND AND/OR TANTALUM COMPOUND	KIKUYAMA, HIROHISA
10505806	Not Issued	71	08/26/2004	Method of purifying niobium compound and/or tantalum compound	KIKUYAMA, HIROHISA
10514192	Not Issued	93	06/13/2005	METHOD OF PURIFYING QUATERNARY ALKYLAMMONIUM SALT AND QUATERNARY ALKYLAMMONIUM SALT	KIKUYAMA, HIROHISA
10551113	Not Issued	30	06/28/2006	Method for analyzing impurities (color centers) of fluoride and process for producing material for growing single crystal	KIKUYAMA, HIROHISA
*10554424	Not Issued	25	10/26/2006	Apparatus for producing fluoride crystal	KIKUYAMA, HIROHISA
*10555384	Not Issued	25	01/16/2007	Chitin oligomer composition and/or chitosan oligomer composition and processes for preparation thereof	KIKUYAMA, HIROHISA

<u>10564283</u>	Not Issued	30	05/25/2006	Method for producing crystal of fluoride <i>Applicant's Inventor</i>	KIKUYAMA, HIROHISA
<u>10569488</u>	Not Issued	30	06/23/2006	Scintillator and radiation detector, and radiation inspecting device	KIKUYAMA, HIROHISA
<u>10592360</u>	Not Issued	25	11/14/2006	Tantalum oxide and/or niobium oxide and method for preparation thereof	KIKUYAMA, HIROHISA
<u>10592372</u>	Not Issued	30	11/14/2006	Method for producing tantalum oxide and/or niobium oxide in form of hollow particle	KIKUYAMA, HIROHISA
<u>10609834</u>	<u>6821452</u>	150	06/27/2003	ETCHANT	KIKUYAMA, HIROHISA
<u>10844704</u>	Not Issued	61	05/12/2004	Surface treating for micromachining and surface treatment method	KIKUYAMA, HIROHISA
<u>11547199</u>	Not Issued	20	02/28/2007	Carbon Nanotubes Aggregate, Method for Forming Same, and Biocompatible Material	KIKUYAMA, HIROHISA
<u>11722120</u>	Not Issued	19	01/01/0001	FINE TREATMENT AGENT AND FINE TREATMENT METHOD USING SAME	KIKUYAMA, HIROHISA

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PALM INTRANET**Inventor Name Search Result**

Your Search was:

Last Name = FUKUDA

First Name = TSUGUO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>05776207</u>	<u>4144117</u>	150	03/10/1977	METHOD FOR PRODUCING A LITHIUM TANTALATE SINGLE CRYSTAL	FUKUDA, TSUGUO
<u>05838448</u>	<u>4154025</u>	150	10/03/1977	METHOD FOR PREPARING OXIDE PIEZOELECTRIC MATERIAL WAFERS	FUKUDA, TSUGUO
<u>06115195</u>	<u>4371419</u>	150	01/25/1980	METHOD FOR PRODUCING A LITHIUM TANTALATE SINGLE CRYSTAL	FUKUDA, TSUGUO
<u>06336701</u>	<u>4431476</u>	150	01/04/1982	METHOD FOR MANUFACTURING GALLIUM PHOSPHIDE SINGLE CRYSTALS	FUKUDA, TSUGUO
<u>06336708</u>	<u>4397813</u>	150	01/04/1982	APPARATUS FOR MANUFACTURING SINGLE CRTSTALS	FUKUDA, TSUGUO
<u>06455734</u>	<u>4496424</u>	150	01/05/1983	METHOD FOR MANUFACTURE OF III-V COMPOUND SEMICONDUCTING SINGLE CRYSTAL	FUKUDA, TSUGUO
<u>06508091</u>	<u>4539067</u>	150	06/27/1983	METHOD AND APPARATUS FOR MANUFACTURING SINGLE CRYSTALS	FUKUDA, TSUGUO
<u>06571091</u>	<u>4637854</u>	150	01/16/1984	METHOD FOR PRODUCING GaAs SINGLE CRYSTAL	FUKUDA, TSUGUO
<u>06571194</u>	<u>4606037</u>	250	01/16/1984	APPARATUS FOR MANUFACTURING SEMICONDUCTOR SINGLE CRYSTAL	FUKUDA, TSUGUO
<u>06596705</u>	<u>4586979</u>	150	04/04/1984	METHOD FOR MANUFACTURE OF III-V GROUP COMPOUND	FUKUDA, TSUGUO